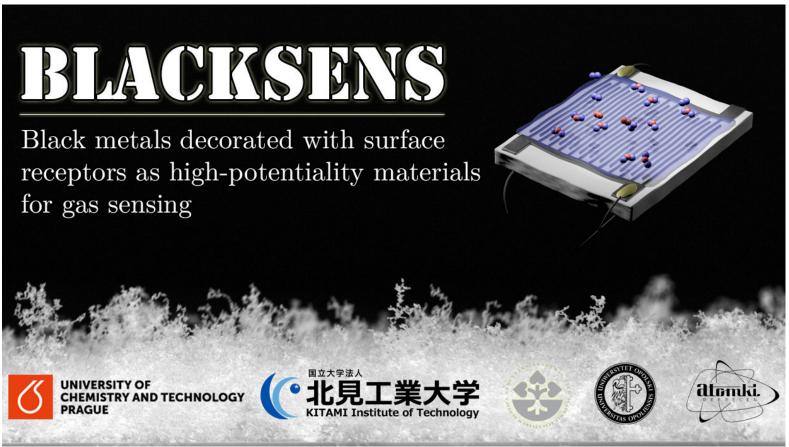
Visegrad Group (V4) + Japan
- Innovation and Industry Joint Science Diplomacy Seminar



• Visegrad Fund

11:30 9 March 2022



Presenter: Prof. Midori Kawamura, JAPAN





The Japanese groups are in Hokkaido



Research groups of BLACKSENS

Principal Project Leader

Czech Republic

Dr. P. Fitl

Univ. of Chem. Tech. Prague (UCT Prague) **Secondary Project Leader**

Japan

Dr. M. Kawamura

Kitami Inst. of Tech. (KIT)

Japan

Dr. M. Ueda

Hokkaido Univ.

Slovakia

Dr. M. Mičušík

Polymer Institute of Slovak Academy of Sciences(PISAS) Poland

Dr. G. Dydra

Univ. Opole

Hungary

Dr. T. Fodor

Institute for Nuclear Research (ATOMKI)

Research background of **BLACKSENS**

NOx is a pollutant that affects the human body and the environment, and <u>organic nitrate</u> is an explosive marker, so accurate detection is important.

We develop a low-cost sensor that can detect low-concentration NOx -based gases with high sensitivity at room temperature.

The sensor consists of quartz crystal microbalance (QCM), black metals (BM) and receptors

Quartz Crystal microbalance (QCM) and Black metals

QCM

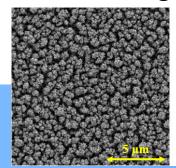
 An AT-cut quartz crystal vibrates at a constant frequency when ac voltage is applied.

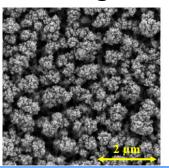


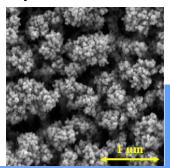
- Deposition/adsorption of substance → frequency decreases
- $\Delta f = -rac{2f_0^2}{A\sqrt{
 ho_q\mu_q}}\Delta m$
- Detecting the frequency change → mass change of the substance

Black metals (BM)

- Densely porous cauliflower-like surface structure, which is responsible for trapping incident light, resulting in the black color
- High potencial in the gas sensing device, due to the high surface to volume ratio, offering numerous bonding sites for gas analytes







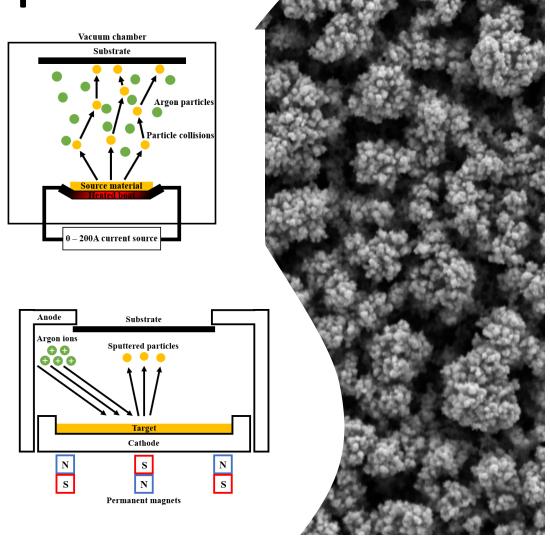
Deposition techniques

Thermal evaporation:

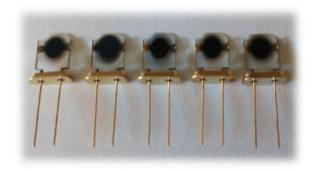
Evaporation of the source material in the inert atmosphere of argon with pressure about hundreds of pascals. The evaporated material is losing its kinetic energy and stays on the substrate in arbitrary positions

Magnetron sputtering:

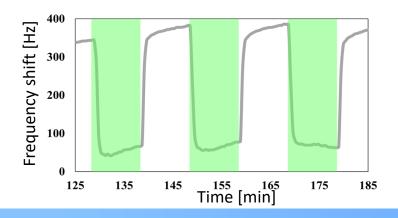
the target material is bombarded by the argon ions. Sputtered particles then stick to the sustrate

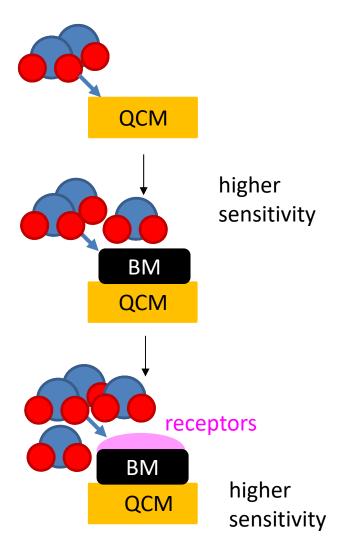


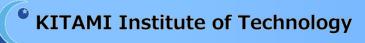
BM on QCM Substrate



- Exposure to the gas analyte causes the resonant frequency shift of the QCM crystal.







Research Goals

Aiming to improve sensor characteristics

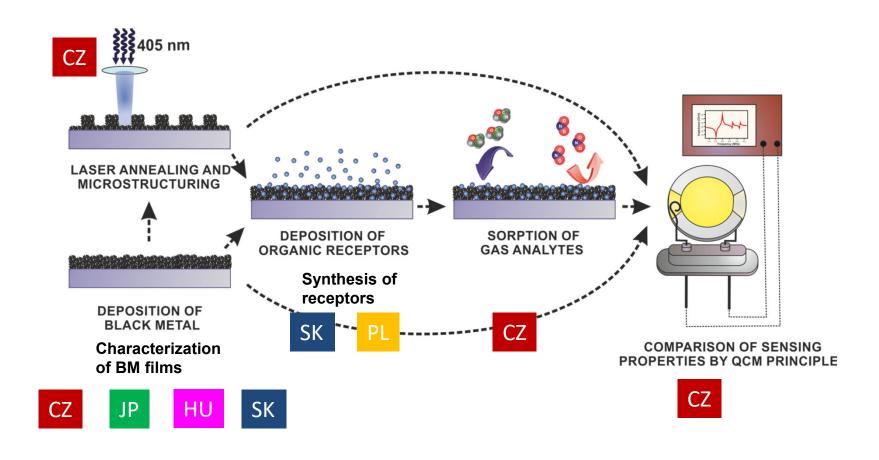
10 ppm NO₂ has been detected with BM films without receptors. Achieve the detection limit of 1ppm by the effect of receptors, etc.

Important items to achieve this goal:

- 1. porosity and stability of BM films
- 2. Selection of BM film constituent metals (and alloys)
- 3. Development of organic and inorganic surface receptors.

These explorations will be accomplished through V4-Japan cooperation.

How to fabricate the QCM sensors



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and Tech.

Prague

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Polymer Institute of Slovak Academy of Sciences

Poland

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Univ. Opole

Hungary

Dr. T. Fodor

Institute for Nuclear Research (ATOMKI)

UCT Prague Sensor Group









Dr. Přemysl Fitl

Dr. Michal Novotný

- one of the research groups at the
 Department of Physics and
 Measurements, a part of Faculty of
 Chemical Engineering
- 11 members

Research

- Preparation and characterization of thin film structures for chemical gas sensors (Black metals, Inorganic semiconductors, Organic semiconductors, Polymer Ionic Liquids, Composites and Nanocomposites)
- PVD, CVD, PLD processes
- Design and development of gas sensors and sensor substrates
- Security systems of early detection (chemical warfare agents and taggants of explosives)
- Industrial systems for detection of hazardous gases and vapors (NO₂, NH₃, CO...)
- Monitoring systems of environmental pollution

KITAMI Institute of Technology

Sensor Group

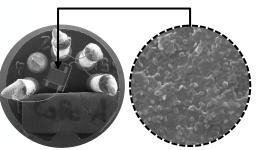
Technologies + Analyses – gas sensing

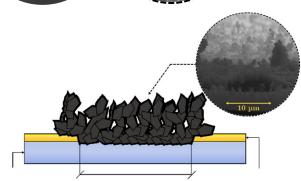
- Measurement of impedance in frequency range from 0,001 Hz up to 110 Mhz
- Measurement of DC resistance in range from $1\mu\Omega$ up to 1T Ω
- Gas chromatograph with IMS detector, Gas analyzer with quadrupole mass filter
- Preparation of gas mixtures (permeation, gas mixing)
- QCM measurements

Selected Projects – gas sensing

- **Czech Science Foundation (GACR)** project no. 22-14886S, Advanced chemoresistive device based on gas sensitive single-1D nanostructures (2022-2024)
- Czech Science Foundation (GACR) project no. 19-02804S, Nanostructured heterojunctions for chemiresistors (2019-2021)
- **Ministry of Industry and Trade of the Czech Republic**, project no. FV20350, Chemiresistors Based on Nanocomposite Layers for Gas Detection (2017-2021)
- **Ministry of the Interior of the Czech Republic**, project no. VI20192022155, Advanced semiconductor sensors for hazardous industrial gases (2019-2022)
- **Ministry of Education, Youth and Sports** project no. LTC17058, Nano-Carbon Composite Materials for Thin Film Chemical Gas Sensors and Photovoltaics (2017-2020)
- **Czech Science Foundation (GACR)** project no. 17-13427S, Detection mechanisms on chemiresistors with a sensitive layer based on nanostructured oxides (2017-2019)
- **NATO Science for Peace and Security** project no. CEP-SPS NATO 984597, Solid state gas sensors against security and military threats (2014-2017)









Sensor Group

Selected Equipments



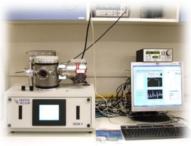
In-house developed systems for measurement of QCM sensor properties, Impedance analysers 4294A and E4990A



HV - Pulsed laser deposition system



In-house developed systems for measurement of sensor properties,
Electrometer Keithley 6517A and
Keysight 34465A - precise
measurement of high resistance
materials with in-house fixtures with
triaxial interconnection



Denton DeskV TSC **DC Magnetron sputtering** deposition system



Laser-Induced Forward transfer system. System is based on Micro-CNC machine (Gravos GV-21) with resolution ~300 nm with diode laser wavelength of 405 nm, with power up to 200 mW



HV - Deposition system
combining molecular
evaporator (Creaphys DE-FR/2.2), thermal boat
evaporator and pulsed laser
deposition



UHV - Deposition system combining two molecular evaporators and one boat evaporator, simultaneous deposition of various materials



Nd:YAG Laser Quantel Brilliant 4th harmonics – 266 nm, 4ns, 45mJ



Chemiresistor substrates KBS4 developed in cooperation with company TESLA Blatna



VarioCAM HD **thermal camera** with microscope lens – resolution ~ 35μm



Quantum Design
PPMS (Physical
Property
Measurement
System) with modules
for measurement of
electro-transport and
magnetic properties
in temperature range
1.85-400 K and
magnetic fields up to



Kitami Institute of Technology

- National university corporation established in 1960.
- 2,000 students from all over Japan and abroad.



Thin Film Electronic Materials Lab.



M. Kawamura



Prof. Y. Abe

OLEDs, smart window, low-E coating, etc.



Assoc.Prof. Kiba

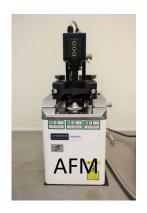


vacuum evaporator



sputtering apparatus





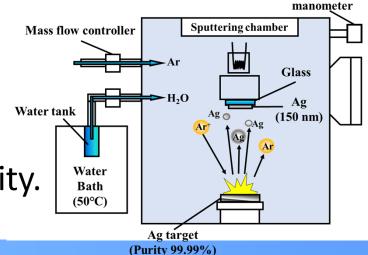
Our tasks

- Preparation of BM film by PVD method
- Development of a new BM film fabrication process, especially by deposition at liquid nitrogen temperature.

The substrate can be cooled down to liq.N2 temp. Water vapor can be introduced into the chamber.

Characterization of BM films

 Determination of the relationship between the physical properties of various BM films and their porosity.



Hokkaido University, Faculty of Eng.

established in 1876. 18,000 students are enrolled.



Fabrication of BM Films by Electrochemical Methods



Au Au Al Au Al Au Al Au Al Au Au Au Al



Au Au

Porous film Au Au Au Au Au

Selective dissolution of Al

Co-deposition of Al and Au using non-aqueous liquids (ionic liquids, molten salts)

Ar atmosphere glove box

Comparison of properties with BM films prepared by PVD method



Prof. Mikito Ueda **Environmental Materials Science lab**

Institute for Nuclear Research (ATOMKI) Establishe

Established in 1954 by Prof. Sándor SZALAY.



- Number of researchers 100, total number of staff around 200
- PhD students connected to the educational program of University of Debrecen (UD)



Laboratory of Materials Science

Electron
Cyclotron
Resonance
(ECR)
laboratory

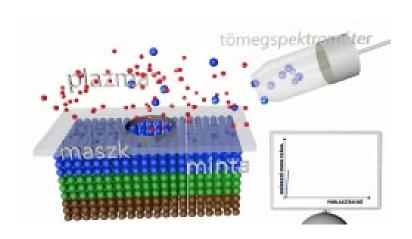


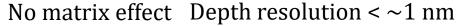
Dr. T. Fodor



Dr. A. Csik

> Secondary Neutral Mass Spectrometer (SNMS)







- performing SNMS depth profiling of the samples
- morphological, cross-sectional and structural analysis
- to determine of relationship between observed sample structure and sample preparation procedures
- to give the feedback how to modify and improve the sample preparation procedures
- to provide output (studies) for colleagues to improve deposition procedures

Opole Univ. Institute of Chemistry







University of Opole Headquarters



Institute of Chemistry



Dr. Gabriela Dyrda



Prof. Rudolf Słota



The main task is to synthesize a series of commercially not available phthalocyanine and porphyrin materials, to be used as sensing layers deposited on black metal thin films (*i.e.* surface receptors).

Characterization include UV-VIS-NIR absorption and emission spectroscopy, FTIR, SEM/EDS, AFM, DSC, HPLC-GC, GC-MS. Photochemical activity are investigated.

First, sandwich phthalocyanine complexes including lanthanide metals will be prepared.





KITAMI Institute of Technology

Polymer Institute of Slovak Academy of Sciences (PISAS)

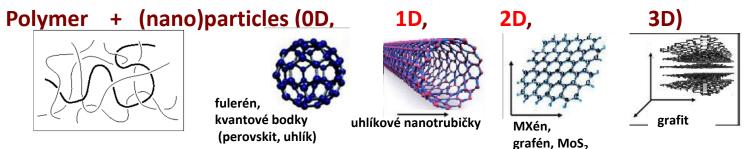


Department of Composite Materials





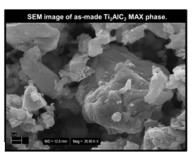
Dr. Matej Mičušík and colleagues

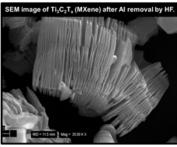


hybrids with conducting polymers (popypyrrole)

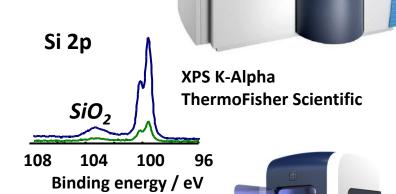
Synthesis and Characterization

 Preparation of 2D nanosheets of exfoliated 2D nanomaterials (MXene, graphene).





 surface and interface properties of prepared BM film by XPS.

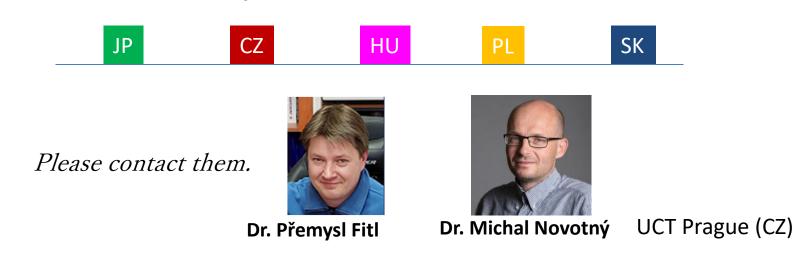


 nanomechanical properties and surface morphology of prepared heterostructured BM films will be studied by Nanoindentation.

Nanoindentor HysitronTl-750

We hope to achieve synergy through our collaboration to achieve our research goals and to promote networking among researchers.

http://blacksens.vscht.cz/



Acknowledgements

We acknowledge for support project No. JP22420 from the International Visegrad Fund, JST SICORP Grant Number JPMJSC2108, Japan.





